

## RABIN & BERDO, P.C.

Specializing in Patent, Trademark , And Copyright Law

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June 27, 2003

In Affiliation with Weiss, Moy & Harris, PC having offices in Arizona and Nevada, and in Washington, DC with Rabin & Berdo, PC



Attorney Reference: MAE 286



Mail Stop Patent Application

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Re:

Steven M. Rabin

Robert H. Berdo, Jr.

Phillip G. Avruch

Allen Wood

New Patent Application of: Toshio NAGATA

Title: METHOD OF FABRICATING A SEMICONDUCTOR DEVICE

INCLUDING A TUNNEL OXIDE FILM

Sir:

Please find attached hereto an application for patent which includes:

- Specification, Claims and Abstract (16 Pages) [x]
- 7 Sheets of Formal Drawings (Fig. 1 through Fig. 7) [x]
- Inventor's Declaration and Power of Attorney (3 Pages) [x]
- Assignment document with cover page (2 Pages) [x]
- Claim for priority and Priority document [x]
- Information Disclosure Statement, Form PTO-1449, and copy of 1 cited [x]reference
- Fee (see formula below) [x]

Additional Fees:	\$ <u>/30.00</u>
Total number of claims: 18 in excess of 20: 0 times \$18/9	\$0.00
Number of independent claims: 1 in excess of 3: 0 times \$84/42	\$0.00
Multiple Dependent Claims \$280/140	\$0.00
Recording Fee \$40.	\$40.00
TOTAL FEES FOR THE ABOVE APPLICATION	<b>\$</b> 790.00

In the event there is attached hereto no check, or a check for an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The rights of priority are claimed under 35 USC §119 of Japanese Application No. 2002-311122, filed October 25, 2002.

June 27, 2003

Date RHB:tz Robert H. Berdo, Jr. (Reg. No. 38,075)

Customer No. 23995

Respectfully submitted

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